

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Kaisaki et al.

Group Art Unit: To Be Determined

Serial No.: To Be Determined

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Examiner: To Be Determined

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Date of Deposit	Printed Name of Person Mailing Application
November 6, 2000	Kara R. Welle

PRELIMINARY AMENDMENT

Commissioner for Patents
Washington, DC 20231

Dear Sir:

Preliminary to examining the above referenced patent application, please amend the application as follows:

Please cancel claims 1-15.

Please add new claims 16-35 as follows:

16. A working liquid useful in modifying a surface of a wafer suited for fabrication of a semiconductor device, the liquid being an aqueous solution of initial components substantially free of loose abrasive particles, the components comprising:
- an oxidizing agent;
 - a complexing agent; and
 - a passivating agent.
17. The working liquid of claim 16 further comprising a buffer.
18. The working liquid of claim 17 wherein the buffer is an ionic buffer.

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